

# APPLICATION DATA SHEET

Electronic Version 0.0.11

Stylesheet Version: 1.0

Attorney Docket Number: 740756-2678

Publication Filing Type: new-utility

Application Type: utility

Title of Invention: MANUFACTURING METHOD FOR SEMICONDUCTOR DEVICE

## Legal Representative:

Attorney or Agent: Jeffrey L. Costellia

Registration Number: 35483

Customer Number Correspondence Address: 22204

**\*22204\***

## Foreign Priority:

2002-366618

JP 2002-12-18

Priority Claimed

Assignee (Publish): Semiconductor Energy Laboratory Co., Ltd.

398, Hase,

Atsugi-shi, 243-0036 Kanagawa-ken JP

## INVENTOR(s):

Primary Citizenship: JAPAN

Given Name: Shigeharu

Family Name: MONOE

Residence City: Atsugi, Kanagawa

Residence Country: JP

Address: c/o Semiconductor Energy Laboratory Co., Ltd.

398, Hase,

Atsugi-shi, Kanagawa-ken, 243-0036 JP

Primary Citizenship: JAPAN

Given Name: Takashi

Family Name: YOKOSHIMA

Residence City: Atsugi, Kanagawa

Residence Country: JP  
 Address: c/o Semiconductor Energy Laboratory Co., Ltd.  
 398, Hase,  
 Atsugi-shi, Kanagawa-ken, 243-0036 JP

- Primary Citizenship: JAPAN  
 Given Name: Shinya  
 - Family Name: SASAGAWA  
 Residence City: Atsugi, Kanagawa  
 Residence Country: JP  
 Address: c/o Semiconductor Energy Laboratory Co., Ltd.  
 398, Hase,  
 Atsugi-shi, Kanagawa-ken, 243-0036 JP